

Carrier Loading System - Advanced (CLSA234)

The Carrier Loading System - Advanced 234 is used for the automatic loading and unloading of wafer out/in the wafer cartridges.

One wafer can be selectively taken out of the cartridge over a vacuum grip arm and be put down on a camp plate. Here the vacuum arm turns to 180 degrees.

In each case one type of wafer per equipment applicable; alternatively are - without change at the equipment - automatically 2", 3" or 4" processable.

The recognition of carrier and wafer size takes place automatically and reliable in service.

Optionally the equipment can be equipped with a OCR recognition.



Electrical connection data

Supply voltage	110 – 240 V
Capacity maximally	200 Watt
Frequency	50/60 Hz
Safety class system	I
Connecting cable	US, Euro, UK or Japan
Connection	Cold device plug 3-pin

Vacuum

Vacuum	-65 KPa (-19inchHg)
Vacuum hose connector	ID 6, AD 8

Generally

Width	270 mm
Height	550 mm
Depth	580 mm
Weight	about 30 kg

Order remarks

32277	CLSA 234"
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